



Date: July 29, 2004



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109120		APPLICATION NO. 09/819,688	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Eiji NATORI			
				FILING DATE March 29, 2001		GROUP 2813	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
HD		5,624,720	04-29-1997	Osada et al.	—	—	
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
HD		EP 0 828 012 A1	03-11-1998	Europe	—	—	
HD		FR 2 729 400 - A1 w/abstract	07-19-1996	France	—	—	
HD		WO 93/16811	09-02-1993	WIPO	—	—	
HD		WO 97/33013	09-12-1997	WIPO	—	—	
HD		WO 99/02756	01-21-1999	WIPO	—	—	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
HD		Jpn. J. Appl. Phys. Vol. 33 (1994) pp. 5135-5138 Part 1, No. 9B, Sept. 1994; Effects of O ₃ on Growth and Electric Properties of Pb(Zr, Ti)O ₃ Thin Films by Photoenhanced Metalorganic Chemical Vapor Deposition.					
/		/	/	/	/		
/		/	/	/	/		
/		/	/	/	/		
EXAMINER		Nathan Doty			DATE CONSIDERED 4/28/05		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: August 1, 2003